

**Notice of References Cited**

Application/Control No.

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Applicant(s)/Patent Under  
Reexamination  
VASSILOVSKI ET AL.

Examiner

Yuwen Pan

Art Unit

2682

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,349,224	02-2002	Lim, Byung Keun	455/466
	B	US-			
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